



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Small et al.

Title: Compositions for Chemical Mechanical Planarization of Copper

Application No.: 10/017,934 Filing Date: December 12, 2001

Examiner: Umez Eronini, Lynette T. Group Art Unit: 1765

Docket No.: CHEM.001US0 Conf. No.: 1435

Certificate of Mailing Under 37 CFR 1.8

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope address to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on 12/12/03

Edleen Bown
Signature

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

PETITION FOR EXTENSION OF TIME

Dear Sir:

A petition for a five-month extension of time within which to respond to the June 12, 2003 outstanding Office Action is respectfully requested, such extension allowing the undersigned until December 12, 2003 to respond.

12/17/2003 AOSMANI 00000039 10017934

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2010.00 OP

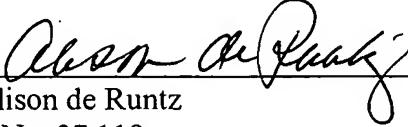
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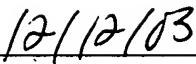
Serial No.: 10/017,934

A check for \$2010.00 is enclosed to cover the fee for a five-month extension of time.

Respectfully submitted,


K. Alison de Runtz

Reg. No. 37,119


Date

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